

Photocathodes Activation Module Conceptual Drawing

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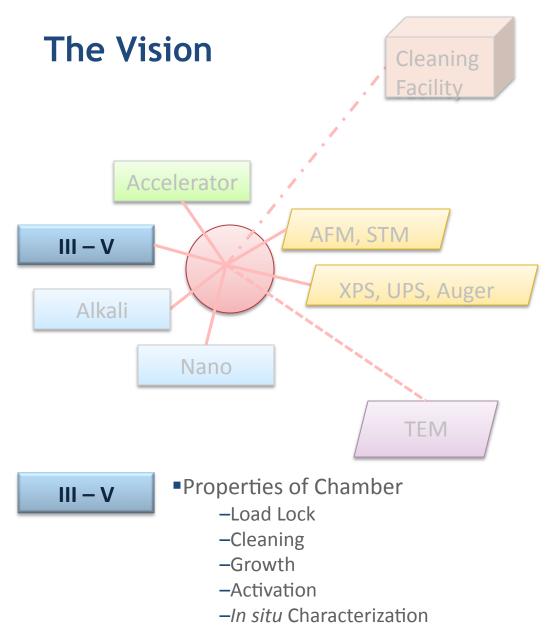
Photocathodes Group Godparent Committee Review

February 26, 2010



Outline

- The Vision of Photocathode Production
- Infrastructure of a Photocathode Growth / Activation Module
- Other Chamber Dimensions
- Proposed Growth / Activation Module
- QE-Characterization Chamber
- CERN Heating Unit
- Proposed Heating Unit
- Conclusion



- Scope of System
 - Growth of Cathodes (variable materials)
 - Activation of Cathodes
 - In situ QE Characterization
 - Characterizing at Incremental Steps during Processing
 - Structure
 - Electronic state
 - Chemical composition
 - Morphology
 - Decay process of Cathode
- Technical Approach
 - Cluster System
 - Standardized Growth Chambers with minimum in situ characterization
 - Dedicated Complex
 Characterization Chambers
 - Interchangeable Units

Infrastructure of a Photocathode Growth or Activation Module

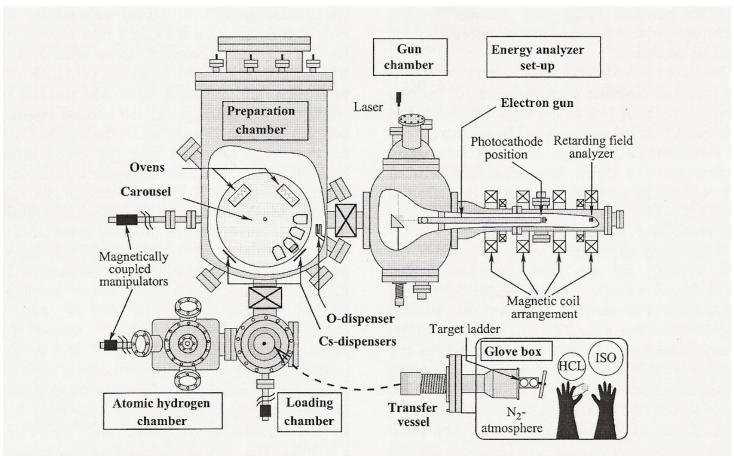


Fig. 3. Top view of the photocathode test bench with an assembled electron energy analyzer and the separate glove box.

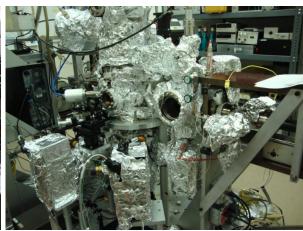


Other Chamber Dimensions

SSL CERN BNL





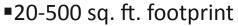




- ■1 sq. ft. footprint
- Fabrication of detection system
- MinimumCharacterization
- Chamber serves as Oven



- ■10 sq. ft. footprint
- Fabrication of detection system
- MinimumCharacterization
- ■Large Size Cathode (8" d)
- ■Minimum Oven size



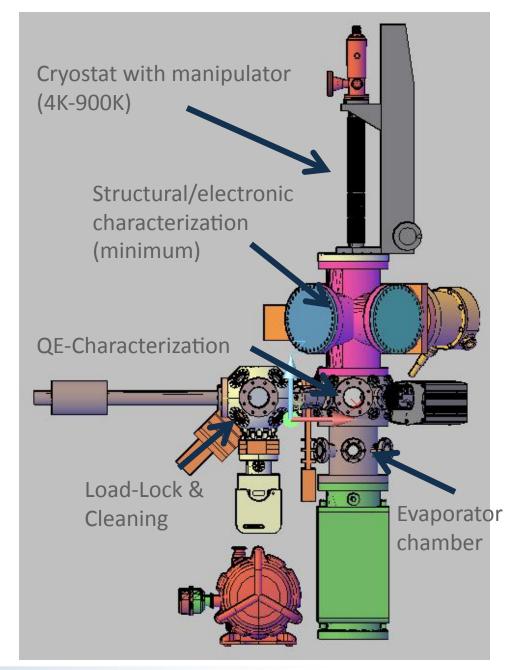
- Cathode Growth /Characterization system
- Insitu Characterization of
 - Structure
 - Chemical Composition
 - Morphology
 - ■Emission Properties ...
- ■Small Size Cathode (1 sq. cm)
- Minimum Oven size





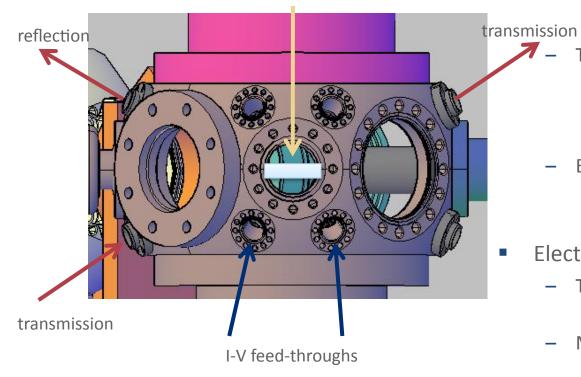
Proposed Growth/ Activation Module

- Chambers
 - Load-Lock
 - QE characterization
 - Optic, electrical
 - Evaporator
 - 6 X 2.5" flange based
 - Boat-type, Cs, E-beam
 - O-gas source
 - Minimum structural characterization (LEED)
- Includes
 - Cleaning Facility (plasma cleaning)
 - Vacuum condition
 - Load-Lock: 10⁻⁷ 10⁻⁹ mbar
 - Main chamber: 10⁻¹⁰ -10⁻¹¹ mbar
 - Capability to Analyze sample sizes
 - 10x10mm²
 - 33mm-diameter



QE-Characterization Chamber

Sample centered in chamber Temperature Range: 4K - 1050K Rotatable f & q



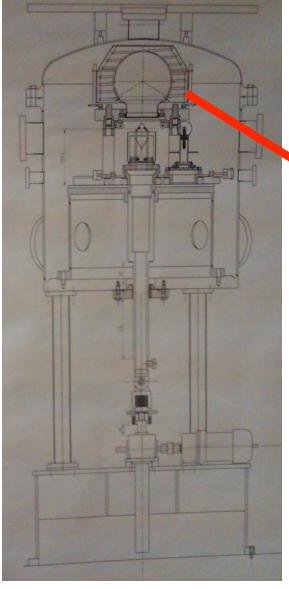
Optional

Laser Characterization (Matth)

- Optic
 - **Work Function**
 - Temperature dependent I-V curve *
 - Spectral dependency of I-V curves*
 - Transmittance, Reflectance, Absorbance
 - Function of wavelength, specular, off-specular
 - Quantum Efficiency QE (λ)
 - Dark Current D(T)
 - Ellipsometry
 - Thickness monitor
 - In situ on sample
- Electrical
 - Triax / BNC Connector design
 - 1 GΩ+ Measurement
 - Measurements on Bulk and Surface
 - Resistivity (2 probe)
 - TCR (temperature coefficient of resistance)
 - Carrier Density
 - Activation Energy of dopants *



CERN Heating Unit

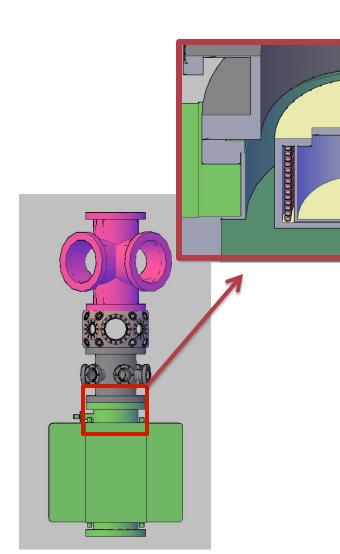




- Thermal Mass determines
 - Turnover
 - Response time
 - Vacuum quality
- Vacuum & Heater
 - Coldest chamber accumulates desorbents
 - Minimizing hot surfaces optimizes Vacuum condition
 - Open Heater v.Capsulated Heater
- Direct Heater v. Black Body Radiator
 - Homogeneity
 - Thermal mass
 - Maximal temperature



Proposed Heating Unit



Capsulated Heater

- T reaches and maintains up to 750° C
- No direct contact between heating elements and sample
- Homogeneous heating
- Furnace Black Body Radiator
 - Heating Coils
 - Optical Furnace
- Cooling Walls
 - Absorb out gassing
 - Minimize Thermal Mass
- Single Sample holder

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